

<b>Notice of References Cited</b>		Application/Control No. 10/532,008	Applicant(s)/Patent Under Reexamination BEMMER ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0203946	10-2004	Wu et al.	455/466
*	B	US-2004/0054732	03-2004	Carter et al.	709/206
*	C	US-2003/0100326	05-2003	Grube et al.	455/515
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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